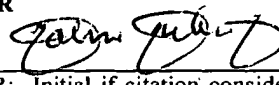



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	K	5,654,819	08/05/97	Goossen, et al.	359	291	01/07/95	
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	M	5,684,631	11/04/1997	Greywall	359	565	05/13/1996	
78	N	5,661,592	08/26/1997	Bornstein, et al.	359	291	01/07/95	
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73	D	5,825,528	10/20/1998	Goossen	359	291	12/26/95	
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78	I	5,870,221	02/09/1999	Goossen	359	290	07/25/97	
79	J	5,914,804	06/22/1999	Goossen	359	291	01/28/98	
80	K	5,943,155	08/24/1999	Goossen	359	247	08/12/98	
81	L	5,943,158	08/24/1999	Ford, et al.	359	295	05/05/98	
82	M	5,943,454	08/24/1999	Aksyuk, et al.	385	22	08/15/97	
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88	C	5,986,796	11/16/1999	Miles	359	260	11/05/1996
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